

FIG 1: PLASMA SPUTTER DEPOSITION SYSTEM

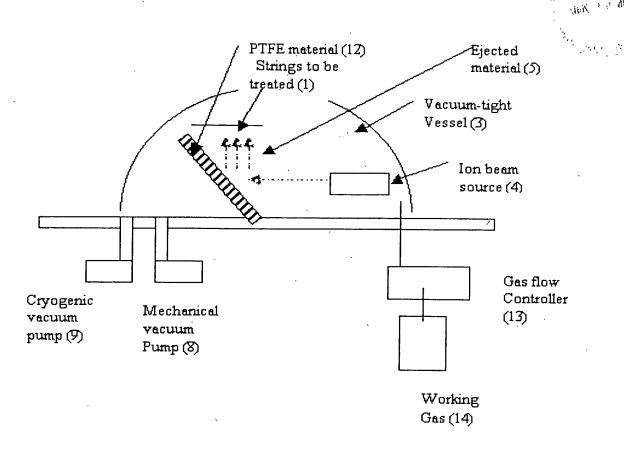


FIG 2: ION BEAM DEPOSITION SYSTEM

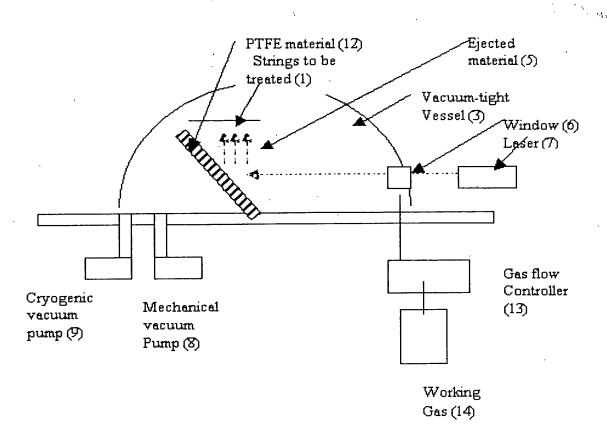


FIG 3: LASER DEPOSITION SYSTEM

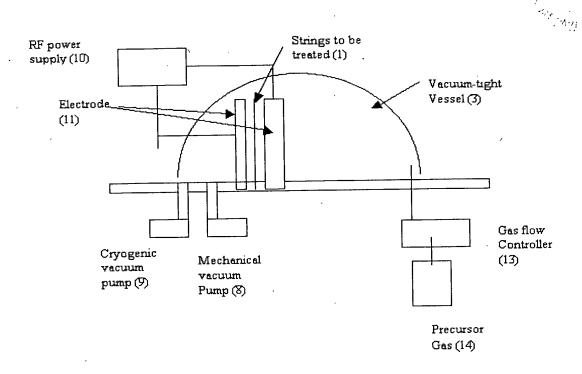


FIG 4: PLASMA CHEMICAL VAPOR DEPOSITION SYSTEM

7 ° C 2 2 2 4

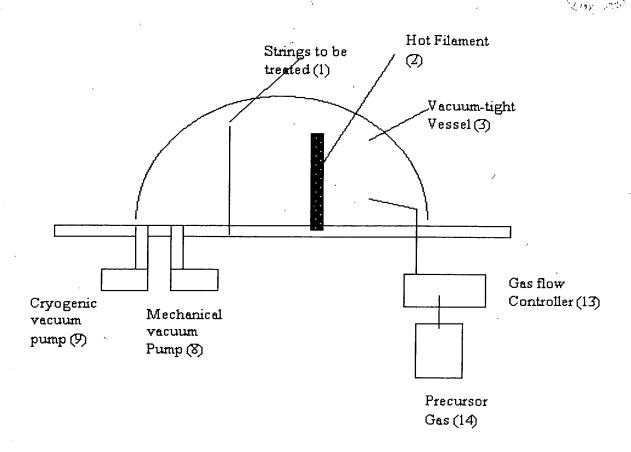


FIG 5: HOT FILAMENT CHEMICAL VAPOR DEPOSITION SYSTEM

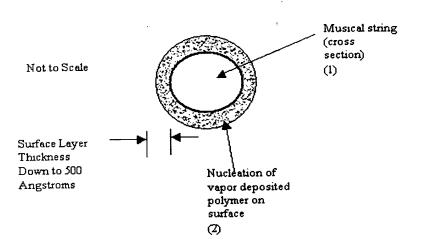


FIGURE 6: MUSICAL STRING TREATED WITH VAPOR DEPOSITED POLYMER

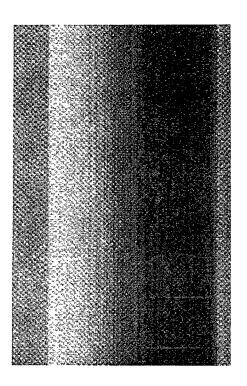


Figure 7



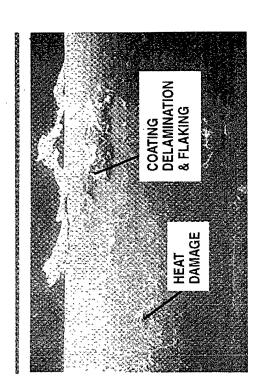


FIGURE 8

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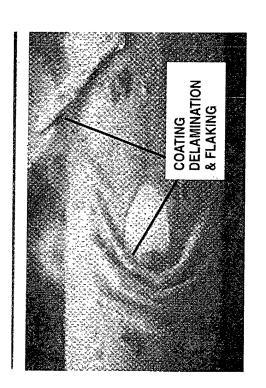


FIGURE 9